



PATENT APPLICATION

#4/A
10
3/6/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q65994

Mitsuaki HATA

Appln. No.: 09/935,569

Group Art Unit: 1765

Confirmation No.: 8860

Examiner: Terrence Mackey

Filed: August 24, 2001

For: METHOD AND DEVICE FOR REMOVING AN UNNECESSARY FILM

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated December 18, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please enter the following amended claims:

1. (Amended) A method of removing, as an unnecessary film, an unnecessary portion of a resist film formed on a surface of a substrate as a substrate surface, comprising:
- covering said substrate surface with a cover member having a top;
- supplying a solvent from the top of said cover member through a supply hole formed at a predetermined position of said cover member; and
- dissolving said unnecessary film by said solvent;
- the cover member defining a gap between an inner surface thereof and said substrate surface,

RECEIVED
MAR - 6 2003
TC 1700 MAIL ROOM

A1